Notice of Allowability	Application No.	Applicant(s)
	10/811,738	PRINTY ET AL.
	Examiner	Art Unit
	Sang Nguyen	2886
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet with the c (OR REMAINS) CLOSED in this ap) or other appropriate communication IGHTS. This application is subject t	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to <u>Amendment on 08/10</u>	<u>0/07</u> .	
2. The allowed claim(s) is/are <u>1-20</u> .		
 3. ☐ Acknowledgment is made of a claim for foreign priority use a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 		•
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be subminFORMAL PATENT APPLICATION (PTO-152) which giv		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) including changes required by the Notice of Draftspers		948) attached
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date	: :	
(b) ☐ including changes required by the attached Examiner' Paper No./Mail Date	s Amendment / Comment or in the C	Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
 DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 		
Attachment(s) 1. Notice of References Cited (PTO-892)	5. Notice of Informal F	Patent Application
 Notice of Praftperson's Patent Drawing Review (PTO-948) 	6. ☐ Interview Summary	, .
3. ☐ Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Da	te
Paper No./Mail Date	7. Examiner's Amend	
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's Stateme	ent of Reasons for Allowance
	9. 🔲 Other	Sang H. Nguyen Primary Patent Examiner Art Unit 2886

DETAILED ACTION

Allowable Subject Matter

Claims 1-20 are allowed.

The following is an examiner's statement of reasons for allowance:

As independent claims 1 and 14, the prior art of record, taken alone or in combination, fails discloses or render a method for manufacturing an integrated circuit device comprising all the specific elements with the specific combination including of the step of providing a correlation that relates a thickness of a layer of thermal oxide created over a silicon germanium film to a germanium concentration of said silicon germanium film; and determining said germanium concentration of said silicon germanium film by identifying a value of germanium concentration that corresponds to said measured thickness of said layer of thermal oxide in accordance with said correlation in combination with the rest of the limitation of claims 1 and 14. Also, the dependent claims 2-8 and 15-20 are allowed by virtue of their dependence on independence claims 1 and 14.

As independent claim 9, the prior art of record, taken alone or in combination, fails discloses or render a method for manufacturing an integrated circuit device comprising all the specific elements with the specific combination including of the step of creating a plurality of silicon germanium films in which each silicon germanium film has a different germanium concentration; creating a layer of thermal oxide over each of said plurality of silicon germanium films; measuring a thickness of each of said layers of thermal oxide; and correlating said thickness of each of said layers of thermal oxide with

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<u>a corresponding value of germanium concentration</u> in combination with the rest of the limitation of claim 9. Also, the dependent claims 10-13 are allowed by virtue of their dependence on independence claim 9.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sang Nguyen whose telephone number is (571) 272-2425. The examiner can normally be reached on 9:30 am to 7:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tarifu Chowdhury can be reached on (571) 272-2800 ext. 86. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a

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USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

August 17, 2007

Sang ⊮. Nguyen Primary Patent Examiner Art Unit 2886